

**Search Notes**

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Examiner

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Applicant(s)/Patent under  
Reexamination

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Art Unit

3729

**SEARCHED**

Class	Subclass	Date	Examiner
29	603.03- 603.06	7/2/2005	PK
360	294.4-294.7	7/2/2005	PK
	244.8 244.2	↓	
	244 240		
	245.2 245.4		

**INTERFERENCE SEARCHED**

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**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Reviewed Parent Application 09/966,687 (US PAT. 6,657,821)	7/2/2005	PK
Text Search EAST/NPL (IEEE)	7/2/2005	PK